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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Applicant: Konstantin N. Koshelev et al.

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Examiner: Unknown

Group Art Unit: Unknown

U.S. PATENT DOCUMENTS

Examiner's Initials*		Document Number	Date MM/YYYY	Name (Family Name of First Inventor)	Class	Sub Class	Filing Date (if appropriate)
	AR	6,414,438	07/2002	BORISOV et al.	315	111.31	
	BR	4,596,030	06/1986	HERZIGER et al.	378	119	
	CR	4,627,088	12/1986	DOUCET et al.	378	122	
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	HR						
	IR						
	JR						
	KR						

FOREIGN PATENT DOCUMENTS

		Document Number	Date MM/YYYY	Country	Inventor Name		English Abstract		Translation Readily Available	
							Enclosed	No	Enclose	No
	LR									
	MR									
	NR									
	OR									
	PR									
	QR									
	RR									
	SR									
	TR									
	UR									

OTHER (Including in this order Author, Title, Periodical Name, Date, Pertinent Pages, etc.)

	VR	Klaus Bergmann et al., "Highly Repetitive, Extreme-Ultraviolet Radiation Source Based on a Gas-Discharge Plasma," <u>Applied Optics</u> , 1 September 1999, Vol. 38, No. 25, pgs. 5413-5417.			
	WR	European Search Report dated 7 March 2003			
	XR				
	YR				
	ZR				
	AAR				

Examiner

Date Considered:

*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.